

Docket Number MIT-1141		Application Number 09/898,815
Applicant Shi-Chang Wooh		
Filing Date July 5, 2001	Art Unit 2878	

U.S. PATENT DOCUMENTS

*EXAMINER INITIALS	REF	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	FILING DATE IF APPROPRIATE
SY		6,382,028 B1	5/7/2002	Wooh et al.	
SY		6,360,609 B1	3/26/2002	Wooh	
SY		6,351,586 B1	2/26/2002	Krol et al.	
SY		6,324,912 B1	12/4/2001	Wooh	
SY		6,186,004	2/13/2001	Kaduchak et al.	
SY		6,067,391	5/23/2000	Land	
		5,801,312	9/1/1998	Lorraine et al.	
SY		5,760,904	6/2/1998	Lorraine et al.	
SY		5,698,787	12/16/1997	Parzuchowski et al.	
SY		5,684,592	11/4/1997	Mitchell et al.	
SY		5,634,936	6/3/1997	Linden et al.	

FOREIGN PATENT DOCUMENTS

	REF	FOREIGN DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	Translation	
					YES	NO
SY		WO 99/44029 A1	9/2/1999	Wooh	✓	

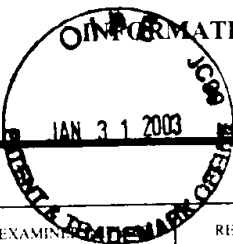
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

5/8/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



Docket Number MIT-114J		Application Number 09/898,815
Applicant Shi-Chang Wooh		
Filing Date July 5, 2001	Art Unit 2878	

U.S. PATENT DOCUMENTS

*EXAMINER	REF	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	FILING DATE IF APPROPRIATE
SY		5,608,166	3/4/1997	Monchalin et al.	
		5,549,003	8/27/1996	Drescher-Krasicka	
SY		5,457,997	10/17/1995	Naruo et al.	
SY		5,402,235	3/28/1995	Monchalin	
SY		5,353,512	10/11/1994	Theurer et al.	
SY		5,257,544	11/2/1993	Khuri-Yakub et al.	
SY		5,079,070	1/7/1992	Chalco et al.	
SY		4,567,769	2/4/1986	Barkhoudarian	
SY		4,541,280	9/17/1985	Cielo et al.	
SY		4,523,469	6/18/1985	Scott et al.	
SY		4,512,197	4/23/1985	von Gutfeld et al.	

FOREIGN PATENT DOCUMENTS

	REF	FOREIGN DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	Translation	
					YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER 	DATE CONSIDERED 5/15/03
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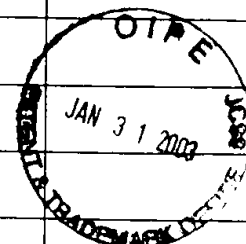
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INFORMATION DISCLOSURE CITATION

Docket Number MIT-114	Application Number 09/898,815
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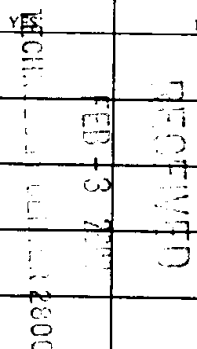
U.S. PATENT DOCUMENTS

*EXAMINER INITIALS	REF	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	FILING DATE IF APPROPRIATE
SV		4,435,984	3/13/1984	Gruber	
SV		4,338,822	7/13/1982	Yamaguchi et al.	
SV		3,978,713	9/7/1976	Penney	
SV		3,829,827	8/13/1974	Ernvein	



FOREIGN PATENT DOCUMENTS

	REF	FOREIGN DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	Translation	
					YES	NO



OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER <i>SV</i>	DATE CONSIDERED 5/8/03
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